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09/965696  
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Subclass  
Class  
ISSUE CLASSIFICATION

**PATENT NUMBER**

**U.S. UTILITY Patent Application**

736 O.I.P.E.  
SCANNED TR3 Q.A. Am

**PATENT DATE**

APPLICATION NO. 09/965696	CONT/PRIOR F	CLASS 204	SUBCLASS 164	ART UNIT 1747 1753	EXAMINER MAYEKAR
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## APPLICANTS

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Catalyst reactor for processing hazardous gas using non-thermal plasma and dielectric heat and method therefor

### TIME

PTO-2040  
12/99

## **ISSUING CLASSIFICATION**

TERMINAL DISCLAIMER	DRAWINGS			CLAIMS ALLOWED	
	Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims	Print Claim for O.G.
<input type="checkbox"/> The term of this patent subsequent to _____ (date) has been disclaimed.	(Assistant Examiner) _____ _____			<b>NOTICE OF ALLOWANCE MAILED</b>	
<input type="checkbox"/> The term of this patent shall not extend beyond the expiration date of U.S Patent No. _____  _____ _____	(Primary Examiner) _____ _____				
<input type="checkbox"/> The terminal _____ months of this patent have been disclaimed.	(Legal Instruments Examiner) _____ _____			<b>ISSUE FEE</b> Amount Due      Date Paid	
				<b>ISSUE BATCH NUMBER</b> _____	

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